Se	earch Notes							

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/526,344	KEMP, STEWART		
Examiner	Art Unit		
Michael Trettel	2672		

	SEARCHED				
Class	Subclass	Date	Examiner		
5	124,126,1 89,190,21 0,412,244, 10	10/26/2006	МТ		
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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